

Electronic Patent Application Fee Transmittal

Application Number:	10751898			
Filing Date:	07-Jan-2004			
Title of Invention:	Plasma processing apparatus and focus ring			
First Named Inventor/Applicant Name:	Shosuke Endoh			
Filer:	Marvin Jay Spivak/Kommala Keovongphet			
Attorney Docket Number:	247409US2			
Filed as Large Entity				
Utility under 35 USC 111(a) Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Submission- Information Disclosure Stmt	1806	1	180	180
Total in USD (\$)				180